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STATEMENT BY APPLICANT**  
( Not for submission under 37 CFR 1.99)

Application Number	10816385
Filing Date	2004-04-01
First Named Inventor	Feng-Wen Sun
Art Unit	2461
Examiner Name	HAILU, Kibrom T.
Attorney Docket Number	PD-203051

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1	Chinese Office Action dated 10/23/2009 in Chinese Patent Application No. 200410049082.5 filed 06/11/2004 by Feng-Wen Sun et al.	<input type="checkbox"/>
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